

## CLAIMS

Therefore, having thus described the invention, at least the following is claimed:

1       1. An apparatus for examining the internal structure of a material, the apparatus  
2       comprising:

3           an x-ray source adapted to emit an x-ray beam at the surface of a target area of the  
4           material;

5           an x-ray detector adapted to detect x-rays diffracted from the target area of the  
6           material; and

7           a mounting plate having the x-ray source and the x-ray detector rigidly mounted  
8           thereto, wherein the x-ray source and the x-ray detector are aligned on the  
9           mounting plate such that the x-ray beam emitted from the x-ray source is  
10          incident upon a given crystallographic plane atoms in the target area of the  
11          material at the Bragg angle for the given crystallographic plane of atoms  
12          and the x-ray detector is configured to detect the x-rays diffracted at the  
13          approximate Bragg angle.

1       2. The apparatus of claim 1, wherein the mounting plate is adapted to have the x-ray  
2       source and x-ray detector rigidly mounted thereto in a finite number of alignments.

1       3. The apparatus of claim 2, wherein for each alignment, the x-ray source and x-ray  
2       detector are aligned such that the x-ray detector detects x-rays that were emitted by the x-  
3       ray source and diffracted from a particular crystallographic plane of atoms at the  
4       approximate Bragg angle for that particular plane of atoms.

1       4. The apparatus of claim 2, wherein the mounting plate defines multiple sets of  
2       alignment bores, each set of alignment bores configured to align and rigidly couple the x-  
3       ray source and the x-ray detector to the mounting plate.

- 1       5. The apparatus of claim 1, further including:  
2           a photo-spectrum analyzer mounted to the mounting plate and adapted to measure  
3               spectral intensity across a range of frequencies for electromagnetic  
4               radiation emitted from the target area of the material.
  
- 1       6. The apparatus of claim 1, further including:  
2           an x-ray source controller in communication with the x-ray source, the x-ray  
3               source controller adapted to provide electrical power and initiation and  
4               operation parameters to the x-ray source.
  
- 1       7. The apparatus of claim 1, further including:  
2           a storage device in electrical communication with the x-ray detector, wherein the  
3               storage device stores information related to the angular dispersion of the  
4               diffracted x-rays.
  
- 1       8. A method for examining the internal structure of a component, the method  
2       comprising the steps of:  
3               aligning an x-ray source and an x-ray detector in a rigid and predetermined  
4               orientation;  
5               irradiating a target area of a surface of a component with an x-ray beam from the  
6               x-ray source, wherein the x-ray beam is incident upon a particular  
7               crystallographic plane of atoms at the Bragg angle for that plane;  
8               detecting x-rays diffracted from the target area of the component with an x-ray  
9               detector, wherein the intensity of the diffracted x-rays exhibits a peak at a  
10              given angle,  $\theta$ , and  $\theta$  is the approximate Bragg angle for the diffracting  
11              crystallographic plane of atoms, and wherein the rigid predetermined  
12              orientation of the x-ray source and x-ray detector is such that the x-ray  
13              detector measures the peak in intensity of the diffracted x-rays; and  
14               determining an indicator of the internal structure from the intensity as a function  
15              angular dispersion of the diffracted x-rays detected by the x-ray detector.

1       9. The method of claim 8, further including the steps of:  
2           enumerating the number of x-rays detected by the x-ray detector over a range of  
3           angles; and  
4           parameterizing the number of x-rays detected as a function of angle.

1       10. The method of claim 9, wherein the indicator of the internal structure is a  
2           parameter used in the parameterization of the number of x-rays counted as a function of  
3           angle.

1       11. The method of claim 8, further including the step of:  
2           identifying the composition of the component.

1       12. The method of claim 11, wherein the step of identifying the composition of the  
2           component includes the steps of:

3           measuring across a frequency range the intensity of light fluoresced from the  
4           composition to determine the spectral characteristics of the composition;  
5           and

6           comparing the spectral characteristics of the composition with spectral  
7           characteristics of known materials.

1       13. The method of claim 8, further including the step of:  
2           mounting the x-ray source and the x-ray detector rigidly and removably on a  
3           mounting plate, wherein the mounting plate is adapted to have the x-ray  
4           source and x-ray detector rigidly and removably coupled thereto in  
5           multiple alignments, wherein for each of the multiple alignments the angle  
6           between the x-ray beam emitted from the x-ray source is at Bragg angle for  
7           a particular crystallographic plane of atoms and the x-ray detector is  
8           aligned to receive the diffracted x-rays at the Bragg angle.

1       14. The method of claim 8, further including the step of:  
2              determining the remaining lifetime of the component using the internal structure  
3              indicator and a database, wherein the database includes structure indicators  
4              having lifetimes associated therewith for multiple test objects.

1       15. The method of claim 8, wherein the component is part of a system and is scanned  
2              in situ.

1       16. An apparatus for non-destructively examining the internal structure of a  
2              component, the apparatus comprising:

3              an x-ray source; an x-ray detector; and  
4              a mounting system having the x-ray source and the x-ray detector rigidly mounted  
5              thereon, wherein the x-ray source emits an x-ray beam that is at least  
6              partially diffracted from the component, and the x-ray source and the x-ray  
7              detector are aligned such that the x-ray detector detects a peak in the  
8              intensity of the diffracted x-rays, wherein the mounting system is adapted  
9              to have the x-ray source and the x-ray detector mounted in multiple  
10             configurations; and

11             a housing defining an exterior surface and a generally hollow interior having the  
12             mounting system therein, the housing defining a window extending from  
13             the interior to the exterior surface, the window adapted to have an x-ray  
14             beam generated in the housing pass through the window;;

1       17. The apparatus of claim 16, wherein the mounting system is an interior wall of the  
2              housing.

1       18. The apparatus of claim 16, wherein the mounting system includes a plate mounted  
2              to an interior wall of the housing.